



00684.003278.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Chidane OUCHI) : Examiner: P. B. Kim
Application No.: 09/986,324) : Group Art Unit: 2851
Filed: November 8, 2001) : Confirmation No.: 5125
For: PROJECTION EXPOSURE APPARATUS AND DEVICE) June 30, 2004
MANUFACTURING METHOD THAT CHANGE A :
RESONATOR LENGTH OF A CONTINUOUS EMISSION)
EXCIMER LASER (As Amended) :

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Official Action dated March 31, 2004, please amend the above-identified application as follows: